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Attorney Docket No.: AM-3396.D1

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Anisul Khan et al.

§ GROUP ART UNIT: 1763

SERIAL NO.: 09/740,146

§

FILED: December 18, 2000

§ EXAMINER: G. A. Goudreau

FOR: APPARATUS FOR PERFORMING SELF-CLEANING
METHOD OF FORMING DEEP TRENCHES IN
SILICON SUBSTRATES

§ Attorney Docket No.: AM-3396.D1

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§ Date: December 30, 2002

INFORMATION DISCLOSURE STATEMENT
TRANSMITTAL LETTER

RECEIVED

Hon. Commissioner for Patents
Washington, DC 20231

JAN - 3 2003
TC 1700

Sir:

Applicants are submitting the subject Information Disclosure Statement under 37 CFR § 1.97(b)(3). This Information Disclosure Statement is being submitted before the mailing of a first Office action.

CERTIFICATE OF MAILING UNDER 37 CFR 1.10

I hereby certify that this paper is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as U.S. EXPRESS MAIL NO. ET163845960US in an envelope addressed to the: Commissioner for Patents, Box DD, Washington, DC 20231.

Date: December 30, 2002

Shirley L. Church
Shirley L. Church, Reg. No. 31,858

Applicants do not believe that any fee is due in connection with the filing of this Information Disclosure Statement under 37 CFR § 1.97(b)(3). However, in the event that any additional fee is due, the Commissioner is hereby authorized to charge Deposit Account No. 50-1512 of Shirley L. Church, Sunnyvale, California, in the amount of such fee.

This transmittal letter is submitted in duplicate for accounting purposes.

Respectfully submitted,

Shirley L. Church

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